



MAIL STOP PCT  
PATENT

IFW

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Application No.: **10/594,635**

PCT Appl. No.: **PCT/JP2005/005766**

Applicant: Yoshiharu OHTA et al.

Filing Date: September 28, 2006

Group Art Unit: Unknown

Title: SEMICONDUCTOR POLISHING COMPOSITION

Docket No.: **2691-000050/US**

**REQUEST FOR RECORDATION OF  
INTERNATIONAL PRELIMINARY EXAMINATION REPORT**

**MAIL STOP PCT**

December 26, 2006

Customer Service Window  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Sir:

Applicant attaches hereto an English translation of the International Preliminary Examination Report which has been issued in connection with the above-identified application. Please make this document part of the prosecution history of the present application.

Respectfully submitted,

HARNESS, DICKEY & PIERCE, P.L.C.

By:



Ray Heflin, Reg. No. 41,060

P.O. Box 8910  
Reston, Virginia 20195  
(703) 668-8000

DJD/HRH:amp

Attachment: International Preliminary Examination Report